

WORLD INTELLECTUAL PROPERTY ORGANIZATION International Bureau



INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(51) International Patent Chambeation 6: H01L 23/02, 21/44, B29C 13/00

(11) International Publication Number:

WO.99/56316

(43) International Publication Date:

4 November 1999 (04.11.99)

(21) International Application Number:

PCT/US99/09020

(22) International Filing Data:

26 April 1999 (26.04.99)

(30) Priority Data: 09/067,698

28 April 1998 (28.04.98)

US

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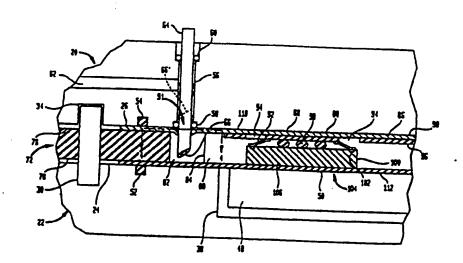
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Published

With international search report.

(54) TILLE: ENCAPSULATION OF MICROPLECTRONIC ASSEMBLIES



(57) Abstract

Microelectronic assemblies are encapsulated using disposable frames (72). The microelectronic assemblies (104) are disposed within an aperture (80) defined by a frame. The sperture is covered by top and bottom scaling layers (110, 112) so that the frame and scaling layers from the encapsulation fixture and held in a curring oven. After cure, the frame is cut apart and the individual assemblies are severed from another. Because the frame need not be held in the encapsulation fixture during curing, the process achieves a high throughput.